



500.41295VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: KAWAGUCHI et al
Serial No.: 10/688,991
Filed: October 21, 2003
For: Plasma Processing Method And Apparatus
Art Unit: 3742
Examiner: T. Hoang

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97 & 1.98

Mail Stop: DD (Fee)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 18, 2005

Sir:

In the matter of the above-identified application, applicants are submitting herewith copies of the documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

This information disclosure statement is being submitted before the mailing date of either a final action or a notice of allowance and is accompanied by the fee of \$180.00 set forth in 37 CFR 1.17(p).

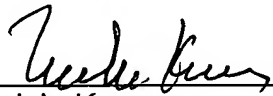
To the extent the documents listed on the attached form equivalent to Form PTO-1449 are not in the English language, the requirement of 37 CFR 1.98(a)(3) for a concise explanation of the relevance is satisfied by an English language version Abstract of the documents.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case: 500.41295VX1), and please credit any excess fees to such deposit account.

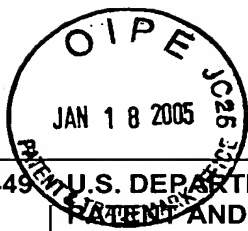
Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP



Melvin Kraus
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Attachments

Form PTO-1449
EquivalentU.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DKT. NO.
500.41295VX1SERIAL NO.
10/688,991INFORMATION DISCLOSURE STATEMENT
BY APPLICANT

(Use several sheets if necessary)

APPLICANT

KAWAGUCHI et al

FILING DATE

T. Hoang

GROUP

3742

U.S. PATENT DOCUMENTS

Ex. Initial	Doc. No.	Date	Name	Class	Subclass	Filing Date
AA						
AB						
AC						
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AE						
AF						
AG						
AH						

U.S. PATENT APPLICATIONS

	Publication Number	Name	Publication Date
AI			
AJ			
AK			
AL			

FOREIGN PATENT DOCUMENTS

	Doc. No.	Date	Country	Class	Subclass	Translation/Abstract?	
						Yes	No
AM	2001-345311	12/2001	Japan			Abstract	
AN	11307519	11/99	Japan			Abstract	
AO	2224232	9/90	Japan			Abstract	
AP	8078339	3/96	Japan			Abstract	
AQ							

OTHER DOCUMENTS

AR	
AS	
AT	

Examiner

Date Considered